



PATENT  
Docket No. 492322014500

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Takashi NOMA *et al.*

Serial No.: 10/696,581

Filing Date: October 30, 2003

For: MANUFACTURING METHOD OF  
SEMICONDUCTOR DEVICE

Examiner: T. S. Pham

Group Art Unit: 2813

**INFORMATION DISCLOSURE  
STATEMENT UNDER 37 C.F.R. § 1.97 & 1.98**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. § 1.97 and § 1.98, Applicants submit for consideration in the above-identified application the documents listed on the attached Form PTO/SB/08a/b. Copies of the documents are submitted herewith. The Examiner is requested to make these documents of record.

Applicants would like to note to the Examiner that the non-patent reference by Thomas Luxbacher, Ph.D. et al. listed on the attached Form PTO/SB/08a/b was filed with a Supplemental Information Disclosure Statement on September 13, 2005, the same date that the Notice of Allowance was mailed.

This Information Disclosure Statement is submitted with the filing of a Request for Continued Examination; accordingly, no fee or separate requirements are required.

Applicants would appreciate the Examiner initialing and returning the Form PTO/SB/08a/b, indicating that the information has been considered and made of record herein.

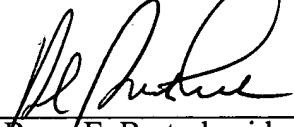
The information contained in this Information Disclosure Statement under 37 C.F.R. § 1.97 and § 1.98 is not to be construed as a representation that: (i) a complete search has been made; (ii) additional information material to the examination of this application does not exist; (iii) the information, protocols, results and the like reported by third parties are accurate or enabling; or (iv) the above information constitutes prior art to the subject invention.

In the event that the transmittal letter is separated from this document and the Patent and Trademark Office determines that an extension and/or other relief is required, applicants petition for any required relief including extensions of time and authorize the Commissioner to charge the cost of such petitions and/or other fees due in connection with the filing of this document to Deposit Account No. 03-1952, referencing Docket No. 492322014500.

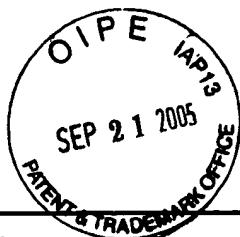
Dated: September 21, 2005

Respectfully submitted,

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ALTERNATIVE TO PTO/SB/08a/b (06-03)

Substitute for form 1449/PTO				<b>Complete if Known</b>	
				Application Number	10/696,581
				Filing Date	October 30, 2003
				First Named Inventor	Takashi NOMA
				Art Unit	2813
				Examiner Name	Thanhha Pham
Sheet	1	of	1	Attorney Docket Number	492322014500

<b>U.S. PATENT DOCUMENTS</b>					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear

<b>FOREIGN PATENT DOCUMENTS</b>					
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	1.	WO-99/40624-A1	8-12-1999		<input checked="" type="checkbox"/> T <sup>6</sup>
	2.	JP-2002-512436-A	4-23-2002		corresponds to WO 99/40624 listed above

\*EXAMINER: Initial if information considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. <sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

<b>NON PATENT LITERATURE DOCUMENTS</b>					
Examiner Initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			T <sup>2</sup>
	3.	Thomas Luxbacher, Ph.D., et al. (7/1999) "Spray Coating for MEMS Interconnect & Advanced Packaging Applications," Fujifilm Interface, 42 <sup>nd</sup> Interface Microlithography Symposium, 5 pages			

\*EXAMINER: Initial if information considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup>Applicant's unique citation designation number (optional). <sup>2</sup>Applicant is to place a check mark here if English language Translation is attached.

Examiner Signature		Date Considered	
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